

Supplementary materials

High-performance and water resistant PVA-based films modified by air plasma treatment

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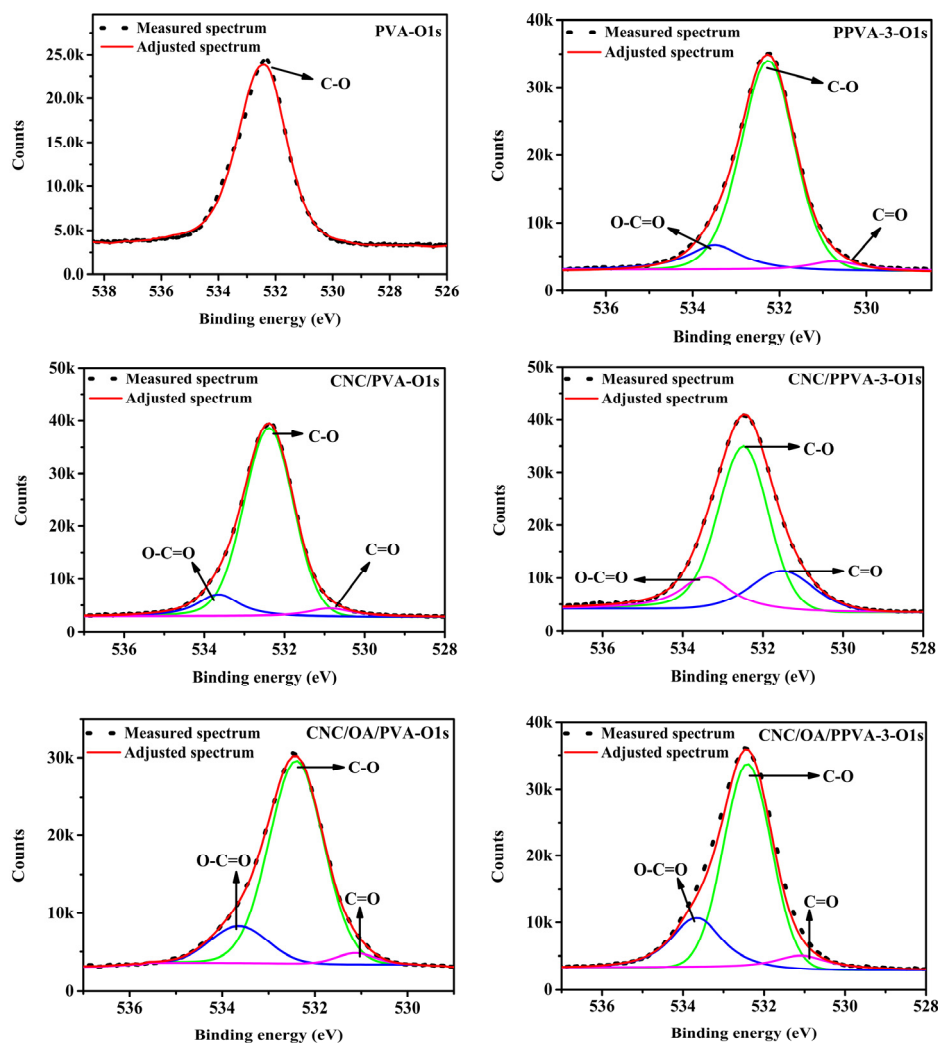


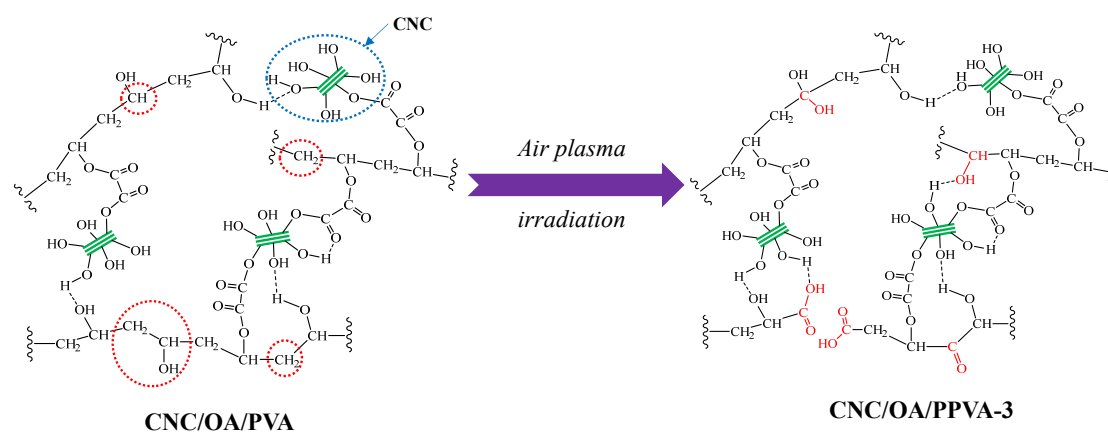
Figure S1. High resolution XPS spectra of O1s of different films without and with air plasma treatment.

Table S1. The temperature at 10% weight loss and residual mass of different PVA-based films.

Samples	Temperature at 10% weight loss (°C)	Residual mass (%)
PVA	264	22.6
PPVA-3	267	8.9
CNC/PVA	271	24.7
CNC/PPVA-3	278	26.1
CNC/OA/PVA	237	11.1
CNC/OA/PPVA-3	252	15.5

Table S2. T_{onset} and T_{DTGmax} values of major weight-loss stages of different PVA-based films.

Samples	Major weight-loss periods			
	The 1 st period		The 2 nd period	
	T_{onset} (°C)	T_{DTGmax} (°C)	T_{onset} (°C)	T_{DTGmax} (°C)
PVA	216	281	382	431
PPVA-3	216	282	382	440
CNC/PVA	207	297	389	429
CNC/PPVA-3	208	294	384	428
CNC/OA/PVA	259	369	414	436
CNC/OA/PPVA-3	259	369	413	437

**Figure S2.** A possible reaction mechanism for air plasma treatment of CNC/OA/PVA film. The groups/linkages before and after air plasma treatment are marked with red-dashed circles and in red font color, respectively.